

FORM HDP-1449 (Based on Form PTO-1449) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Sheet 1 of 2	ATTORNEY DOCKET NO.	SERIAL NO.
	5077-000055/COA	
	APPLICANT	
	Akira Enokihara et al.	
	FILING DATE	GROUP
	Herewith	

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	DT	5,874,870	02/23/1999	Nishiyama et al.	333/202	
2.	DT	6,323,746 B1	11/27/2001	Prager et al.	333/219.1	
3.	DT	6,255,917 B1	07/03/2001	Scott	29/527.2	
4.	DT	6,169,467 B1	01/02/2001	El-Sharawy	333/219.1	
5.	DT	5,805,033	09/08/1998	Liang et al.	333/202	
6.	DT	4,963,841	10/16/1990	Sparagna	333/202	
7.	DT	4,661,790	04/28/1987	Gannon et al.	333/234	
8.	DT	4,639,699	01/27/1987	Nishikawa et al.	333/202	
9.	DT	4,028,652	06/07/1977	Wakino et al.	333/209	
10.	DT	4,725,798	02/16/1988	Igarashi	333/212	

FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes No	
1.	DT	53-076747 A	11/30/1976	Japan	N/A	Partial	
2.	DT	63-110618	05/16/1988	Japan	H01G 4/12	Partial	
3.	DT	63-010603 A	01/23/1988	Japan	H01P 7/10	Partial	
4.	DT	63284902	11/22/1988	Japan	H01P 7/10	Abstract	
5.	DT	63250201	10/18/1988	Japan	H01A 7/10	Abstract	
6.	DT	0 859 423 A1	08/19/1998	Europe	H01P 1/208		
7.	DT	08065006 A	03/08/1996	Japan	H01P 1/20	Abstract	
8.	DT	2000-114809 A	04/21/2000	Japan	H01P 1/205	Abstract	

Examiner: <i>Don Stokola</i>	Date Considered: 9/20/04
------------------------------	--------------------------

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<p>FORM HDP-1449 (Based on Form PTO-1449)</p> <p>PATENT AND TRADEMARK OFFICE</p> <p>INFORMATION DISCLOSURE CITATION</p> <p>(Use several sheets if necessary)</p> <p>Sheet 2 of 2</p>	ATTORNEY DOCKET NO.	SERIAL NO.
	5077-000055/COA	
	APPLICANT	
	Akira Enokihara et al.	
	FILING DATE	GROUP
	Herewith	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.	DT	Farhat Abbas et al., "Ultra-high-Q resonators for low-noise, microwave signal generation using sapphire buffer layers and superconducting thin films"; Superconductor Science and Technology; Vol. 7, No. 7; July 1, 1994; pp. 495-501.
2.	DT	Notice of Reasons of Rejection for Patent Application No. 2001-176674 and English Translation; Mailed September 24, 2003.

Examiner: 	Date Considered: 9/20/04
---	--------------------------

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.